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MANIPAL INSTITUTE OF TECHNOLOGY

MANIPAL

A Constituent Institution of Manipal University

FOURTH SEMESTER B.TECH. (INSTRUMENTATION AND CONTROL ENGG.)

END SEMESTER EXAMINATIONS, JUNE 2017

SUBJECT: SENSOR TECHNOLOGY [ICE 3284]

Time: 3 Hours

MAX. MARKS: 50

Instructions to Candidates:

- ❖ Answer **ALL** the questions.
- ❖ Missing data may be suitably assumed.

- 1A.** Describe the construction of a typical pressure-sensitive potentiometric position sensor. **4**
- 1B.** Define and Differentiate between Sensitivity and Fidelity of a sensor. **4**
- 1C.** Give a brief note on Doppler effect. **2**
- 2A.** Explain the construction and working of a typical LVDT used in position measurement. Also, list the pros and cons of using LVDT (*Any four each*). **5**
- 2B.** Explain with a neat diagram the construction and working of a rotameter. Also mention the limitation(s) of using rotameter for flow measurement. **5**
- 3A.** State and explain the following: **6**
 - (a) Peltier effect.
 - (b) Ferroelectric effect.
- 3B.** State the use of Law of homogeneous metal and also, Law of intermediate metals for thermocouple-based temperature measurement. **4**
- 4A.** Explain the various types of MEMS based pressure sensing techniques. **5**
- 4B.** With relevant diagrams, explain the working of a typical capacitance based-frequency based, absolute micro-pressure sensor. **5**
- 5A.** With relevant figures, explain Category-II Wireless Sensor Networks (C2WSNs). **6**
- 5B.** Discuss on the construction of a typical capacitive accelerometer. **4**